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SERIAL NUMBER 10/666,317	FILING DATE 09/19/2003 RULE	CLASS 438	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 8377/ETCH/SILICON/JB
APPLICANTS David Mui, Fremont, CA; Wei Liu, San Jose, CA; Hiroki Sasano, Sunnyvale, CA; Kyeongran Yoo, Palo Alto, CA;				
** CONTINUING DATA ***** None / EC				
** FOREIGN APPLICATIONS ***** None / EC				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/12/2003				
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged		STATE OR COUNTRY CA	SHEETS DRAWING 6	TOTAL CLAIMS 28
Examiner's Signature <i>E. Chen</i> Initials <i>EC</i>		INDEPENDENT CLAIMS 3		
ADDRESS 44182 MOSER, PATTERSON & SHERIDAN, LLP APPLIED MATERIALS INC 595 SHREWSBURY AVE SUITE 100 SHREWSBURY, NJ 07702				
TITLE Method for controlling critical dimensions during an etch process				
			<input type="checkbox"/> All Fees	